

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Glenn Houser

Application No.: 10/625,830

Filed: July 22, 2003

For:

METHOD AND APPARATUS FOR

MEASUREMENT OF WAFER OR

FILM THICKNESS

MAIL STOP AMENDMENT

Group Art Unit: 2877

Examiner: Richard A. Rosenberger

Confirmation No.: 8963

AMENDMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated September 26, 2005, please amend the above-identified patent application as follows:

Comments regarding the Claims begin on page 2; and Remarks begin on page 8.

12/27/2005 HALI11 00000,059 10625830

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